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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	10/621,046
		Filing Date	7-16-2003
		First Named Inventor	Constantine P.
		Group Art Unit	2891
		Examiner Name	
Sheet 2	of 2	Attorney Docket Number	UCB-6 (B01-108)

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS			
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CC	AI.	N.R. Bieri et al, "Microstructuring by printing and laser curing of nanoparticle solutions", Applied Physics Letters, Vol. 82, No. 20, 19 May 2003, pp. 3529-3531.	
CC	AJ.	N.R. Bieri et al, "Manufacturing of Electrically Conductive Microstructures by Dropwise Printing and Laser Curing of Nanoparticle-Suspensions", Proceedings of IMECE2002, ASME International Mechanical Engineering Congress & Exposition, (© 2002 ASME), November 17-22, 2002, New Orleans, Louisiana, pp. 1-8.	
CC	AK.	D.B. Bogy et al, "Experimental and Theoretical Study of Wave Propagation Phenomena in Drop-on-Demand Ink Jet Devices", IBM J. Res. Develop., Vol. 28, No. 3, May 1984, pp. 314-321.	
CC	AL.	Ph. Buffat et al, "Size effect on the melting temperature of gold particles", Physical Review A, Vol. 13, No. 6, June 1976, pp. 2287-2298.	
CC	AM.	J.P. Dijkman, "Hydrodynamics of small tubular pumps", J. Fluid Mech. (1984), Vol. 139, pp. 173-191.	
CC	AN.	Sawyer Fuller et al, "Ink Jet Fabricated Nanoparticle Mems", Proceedings IEEE 13th Annual International Conference of Micro Electro Mechanical Systems IEEF 2000, Piscataway, NJ (© 2000 IEEE), pp. 138-141.	
CC	AO.	Sawyer B. Fuller et al, "Ink-Jet Printed Nanoparticle Microelectromechanical Systems", Journal of Microelectromechanical Systems, Vol. 11, No. 1, February 2002 (© 2002 IEEE), pp. 54-60.	
CC	AP.	G.V. Shivashankar et al, "Biomolecular recognition using submicron laser lithography", Applied Physics Letters, Vol. 73, No. 3, 20 July 1998 (© 1998 American Institute of Physics), pp. 417-427.	
CC	AQ.	John B. Szczech et al, "Fine-Line Conductor Manufacturing Using Drop-On-Demand PZT Printing Technology", IEEE Transactions on Electronics Packaging Manufacturing, Vol. 25, No. 1, January 2002 (© 2002 IEEE), pp. 26-33.	

Examiner Signature	Chandra Chaudhori	Date Considered	6-05
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